

#### APPLICATION FOR INITIAL CERTIFICATION, OR MODIFICATION, OF RECLAIM LARGE SOURCE STACK FLOW CONTINUOUS MONITOR

<u>Applicant</u> : Please check all that are applicable regarding your submittal:			
Present	Currently or Previously Certified New		
Status:	$(certification no date)^{1}$ Source		
Type Application:	InitialModification / Recertification:CertificationProcess ModificationMonitor Modification		
Source(s) Monitored:	One Source   More than one Source:     (Dedicated)   (specify number of sources)		

Please fill out the requested information below, as completely as possible, and return it to the District c/o Monitoring & Source Test Engineering Branch. If additional space is required, attach supplementary pages to the end of this form.

## 1. APPLICANT, COMPANY, CONTACT INFORMATION

Facility ID No	:		
Facility Permit Holder	:		
Mailing Address	:		
Equipment Location (Also include Company Name if differe from Business License Name listed above			
Company Contact	:	Name	Phone
		Title	E-mail Address
AQMD Contacts	:	Permit Engineer's Name	Phone Extension
		Inspector's Name	Phone Extension

<sup>1</sup> Be sure to attach a copy of certification.

FORM ST-221 : 221cems\_lrgflowapplication.doc (REVISED 10/7/04)

# 2. SOURCE MONITORING DESCRIPTION

# **EQUIPMENT 1:**

AQMD Applica Description : (from Application or Permit, including control equipment)	tion/Permit No. or RECLA	IM Device I.D.				
Operating Rate (incl units):	Design	Normal	Minimum			
Process Characteristic :	Continuous	Intermittent <sup>2</sup>	Batch			
<b>EQUIPMENT 2:</b>						
AQMD Applica Description : (from Application or Permit, including control equipment)	tion/Permit No. or RECLA	IM Device I.D.				
Operating Rate (incl units):	Design	Normal	Minimum			
Process Characteristic :	Continuous	Intermittent <sup>2</sup>	Batch			
EQUIPMENT 3:						
AQMD Applica <b>Description</b> : (from Application or Permit, <i>including control equipment</i> )	tion/Permit No. or RECLA	IM Device I.D.				
Operating Rate (incl units):	Design	Normal	Minimum			
Process Characteristic :	Continuous	Intermittent <sup>2</sup>	Batch			

<sup>&</sup>lt;sup>2</sup> Equipment operates on-demand, is supplemental, or is a back-up to another piece of equipment.

# 3. PROCESS DESCRIPTION

Briefly describe manufacturing and control processes in the space below, and include a simplified process flow diagram in *Appendix A*.

## 4. FLUE GAS AND STACK INFORMATION AT THE FLOW SENSOR LOCATION

Please include a simplified stack diagram in Appendix B.

#### Width Diameter or Length Stack dimensions ft. in ft in Overall stack height ft. in. CEMS probe tip distance in stack from stack wall : ft in. CEMS probe distance downstream from disturbance : ft. in. CEMS probe distance upstream from disturbance : ft in. Reference sample port distance from CEMS probe : (check) Upstream ft. in. Downstream **b. ANTICIPATED RANGE OF STACK EXHAUST GAS PARAMETERS** $NO_x : \_____ to \____ppm$ SO<sub>x</sub>:\_\_\_\_\_to\_\_\_\_ppm Contaminant Gas : (Other gas) CO :\_\_\_\_\_\_\_\_ppm ( ):<u>\_\_\_\_\_to\_\_\_\_ppm</u> ( ):<u>to</u>ppm ():<u>to</u>ppm CO<sub>2</sub>:\_\_\_\_\_to\_\_\_\_% $O_2:$ to % Diluent Gas : ):\_\_\_\_\_*to*\_\_\_\_% ): to % (Other gas) ( ( Particulate Matter: \_\_\_\_\_\_to\_\_\_\_\_ gr/dscf \_in H<sub>2</sub>O Static Pressure \_\_\_\_\_to\_\_\_\_\_ : °F Temperature to : Moisture % to Flow Rate to dscfm :

#### a. STACK SAMPLING LOCATION AND DESCRIPTION

5. FLOW MONITOR DESCRIPTION Please include a simplified flow monitor diagram in *Appendix C* and attach manufacturer's specification sheets.

(Serial numbers shall be submitted when installation is completed)

## a. PRINCIPLE FLOW MONITOR EQUIPMENT

Make	Model	Principle (Pitot tube, ultrasonic, annubar, etc.)	Proposed Range(s)	(check) <sup>3</sup> Dry Wet	
SECONDARY	SECONDARY FLOW MONITOR EQUIPMENT (temperature, pressure correction, etc.)				
Make	Model	Description/Proposed Range			

**b. DATA ACQUISITION, RECORDKEEPING AND REPORTING EQUIPMENT** (*Computer, DAS, PLC, Data Logger, Chart Recorder etc.*) Also indicate which chart recorder/data logger will be used for certification.

Make	Model	Description	

<sup>&</sup>lt;sup>3</sup> Raw meter reading will be to dry or wet conditions, excluding external corrections (If any readings are "wet", be sure to detail how they will be corrected to dry standard conditions in Appendix D)

## 5. FLOW MONITOR COST INFORMATION

		Equipment & Materials	Total System as Installed
Estimated Cost of Ed	quipment :	\$	\$
CEMS Contractor	:		
Address	:		
Phone	:		

#### 6. DETERMINATION OF REQUIRED MONITORING PARAMETERS

Detail, step by step in *Appendix D*, how the flow information will be acquired. Include discussion of how secondary parameters such as temperature, pressure, moisture or acceptable correction factors will be treated to obtain a flue or stack flowrate to standard conditions. If constants or correction factors are to be used to standardize flow, the information must be fully documented and justified according to AQMD standards (include historical data, etc.).

#### 7. COMPUTER PROGRAMMING LOGIC FOR THE PARAMETERS IN SEC. 7

Briefly describe in *Appendix E* how these parameters will be programmed into the data reduction and recording units. Use block diagrams, or a copy of recorded data if needed, to show the location in the program where constants, variables and other parameters are entered. Indicate DAS polling frequency.

#### 8. APPLICABLE PERMITS AND PERMIT CONDITIONS

Please include as attachments, applicable permits and permit conditions (and AQMD correspondence which you feel is helpful) related to all basic and control equipment which will be monitored by this flow monitor.

#### 9. MANUFACTURER'S OR VENDOR'S FLOW MONITOR SPECIFICATIONS

Please attach manufacturer's or vendor's specification sheets for all equipment or devices which relate to this flow monitor.

#### **10. QA/QC PROCEDURES**

A complete Quality Assurance Plan (QAP) concerning this flow monitor must be submitted as a condition of Final Certification, or an existing QAP must be updated as a condition of Re-certification. In this Plan, you must address the on-going maintenance and contingencies necessary to assure the continued reliability of emission information. Discuss scheduled and unscheduled maintenance, contingencies for equipment/CEMS outages and modifications, recordkeeping and reporting, periodic testing, personnel responsible for assuring implementation of this Plan, etc.

## **13. FLOW MONITOR ENCLOSURE** (*Please indicate below*):

Flow monitor will be enclosed in an environmentally-controlled shelter with:
Temperature alarm or record of exceedances of manufacturer's specified operating range.
No provisions for temperature alarm or record (Additional QA certification testing required).

Flow monitor shelter will <u>not</u> be environmentally-controlled (*Additional QA certification testing shall be required*).

## **14. STATEMENT OF CONFIDENTIALITY**

Do you regard any of the information included in this application as confidential? (check)

YES NO - If yes, please explain below, or use additional pages:

(APPLICATION MUST BE SIGNED AND DATED BY RESPONSIBLE COMPANY REPRESENTATIVE)

	SIGNATURE OF COMPANY REPRESENTATIVE			
SIGNATURE:			Date:	
	(NAME)	(TITLE)	(PHONE)	(Date)

#### Please mail or deliver your completed CEMS Application(s) to:

SOUTH COAST AIR QUALITY MANAGEMENT DISTRICT 21865 East Copley Drive Diamond Bar, CA 91765-4182 Mr. Rudy Eden, Manager, Source Test Engineering Branch, Monitoring & Analysis Division

A basic or initial application fee is due with each CEMS Application (Reference: *District Rule 301(i)(5)*, please complete attached Form *ST-400 "RECLAIM & Non-RECLAIM CEMS Plan, Application Fee Processing Form"*). A copy of this application is also available on disk, formatted for MS WORD 97. For more information, please contact us at (909) 396-2281 (*e-mail:* knelsen@aqmd.gov).

C/0:

### APPENDIX A SIMPLIFIED PROCESS FLOW DIAGRAM (Reference Section 3)

Show simple flow/block diagram with basic and control equipment including the exhaust stack where the Flow Monitor will be mounted. Be sure to include by-pass ducts, emergency venting stacks, blanked-off stacks, recirculated flows and influent or effluent flow to or from related processes.

#### **APPENDIX B**

### SIMPLIFIED STACK DIAGRAM (Reference Section 4)

Show the Flow Monitor sampling probe and reference sample port locations (top/crosssection and side views) in the exhaust stack with respect to the upstream and downstream flow disturbances (fans, dampers, transitions, change in stack cross-sectional areas, etc.). Indicate distances and dimensions for the above information.

#### **APPENDIX C**

### SIMPLIFIED FLOW MONITOR DIAGRAM (Reference Section 5)

In the following, please provide a diagram of the Flow Monitor, and how it is configured with respect to secondary monitoring equipment, and data acquisition, recordkeeping, and reporting equipment.

## DETERMINATION OF REQUIRED MONITORING PARAMETERS

# (Reference Section 6)

Detail, step by step, how the parameters checked in *Section 6* will be applied to the final monitoring requirement by use of equations, assumptions, and calculations. (Be sure to detail how corrections will be made to dry, standard conditions, or conditions imposed by rules or permits).

#### **BRIEF DESCRIPTION OF COMPUTER PROGRAMMING LOGIC**

## (Reference Section 7)

Briefly describe how the parameters you described in *Section 6* will be programmed into the data reduction and recording units. Use block diagrams, or a copy of recorded data if needed, to show the location in the program where constants, variables and other parameters are entered. Also include the frequency that each monitoring parameter is polled by the DAS/PLC.